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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
10/773,199	02/09/2004	Kia Silverbrook	MTB18US 8280 EXAMINER	
24011	7590 11/27/2006			
SILVERBROOK RESEARCH PTY LTD			CHOI, HAN S	
393 DARLIN BALMAIN,	NG STREET NSW 2041		ART UNIT	PAPER NUMBER
AUSTRALIA	•		2853	
			DATE MAILED: 11/27/2000	6

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/773,199	SILVERBROOK, KIA				
Office Action Summary	Examiner	Art Unit				
	Han S. Choi	2853				
The MAILING DATE of this communication app		correspondence address				
Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING D/ - Extensions of time may be available under the provisions of 37 CFR 1.1: after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period v - Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tin will apply and will expire SIX (6) MONTHS from the cause the application to become ABANDONE	N. nely filed the mailing date of this communication. D (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on 27 O	<u>ctober 2006</u> .					
2a) ☐ This action is FINAL . 2b) ☑ This	This action is FINAL . 2b)⊠ This action is non-final.					
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
closed in accordance with the practice under E	Ex parte Quayle, 1935 C.D. 11, 45	53 O.G. 213.				
Disposition of Claims		•				
4)⊠ Claim(s) <u>1-54</u> is/are pending in the application.						
4a) Of the above claim(s) is/are withdrawn from consideration.						
5) Claim(s) is/are allowed.						
6)⊠ Claim(s) <u>1-54</u> is/are rejected.						
7) Claim(s) is/are objected to.						
8) Claim(s) are subject to restriction and/o	r election requirement.					
Application Papers						
9) The specification is objected to by the Examine	er.					
10)⊠ The drawing(s) filed on <u>09 February 2004</u> is/are: a)⊠ accepted or b)□ objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Ex						
Priority under 35 U.S.C. § 119						
12) ☐ Acknowledgment is made of a claim for foreign a) ☐ All b) ☐ Some * c) ☐ None of:	priority under 35 U.S.C. § 119(a)-(d) or (f).				
1. Certified copies of the priority documents have been received.						
2. Certified copies of the priority document						
 Copies of the certified copies of the prio application from the International Bureau 		ed in this National Stage				
* See the attached detailed Office action for a list	•	ed				
Attachment(s)						
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	4) Interview Summary Paper No(s)/Mail D					
3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date 10/27/06.	5) Notice of Informal F 6) Other:					

DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1, 4, 12, 19, 22, and 31 are rejected under 35 U.S.C. 103(a) as being unpatentable over lms (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104).

Referring to claims 1, 12, 19, and 31, Ims discloses the basic elements of the claimed invention. Ims teaches an ink jet printhead [10] in [Col. 4, Line 48] shown in Fig. 1. and a printer system in [Col. 4, Lines 7-9]. Ims teaches a plurality of nozzles in [Col. 8, Lines 44-45]. Ims teaches a heater associated with each of the nozzles respectively in [Col. 8, Lines 6-11] and the heater having at least one heater element configured for thermal contact with a bubble forming liquid; such that, heating the heater element above the boiling point of the bubble forming liquid forms a gas bubble that ejects a drop of ejectable liquid from the nozzle in [Col. 5, Lines 39-50]. Ims does not teach the gas bubble subsequently collapsing to a point of collapse that is spaced from any solid surface of the heater elements or the bubble forming chamber.

Keil et al. teaches a bubble collapse occurring at a location well spaced from any solid surface within the inkjet printhead such as the heat transducer [34] in [Col. 4, Lines

48-56] shown in Figs. 3-5 ("spaced from any solid surface" does not mean "spaced from every single surface").

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the teaching of Keil et al. with the printhead of Ims for the purpose of extending the life of the heat transducer [34].

Referring to claims 4 and 22, Ims teaches the gas bubble encircles at least some of the heater element in [Col. 5, Lines 44-51]. ("bubble or water vapor thermally isolates the ink from the heating element" means that bubble is surrounding the heating element.)

3. Claims 2, 3, 8, 13, 20, 21, 27, and 32 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) as applied to claims 1 and 19 above, and further in view of Silverbrook (US Pat. 5,841,452).

Ims in view of Keil et al. disclose the basic elements of the claimed invention except for the heater elements and bubble forming chamber being symmetrical about a longitudinal plane, the bubble forming chamber having a circular cross section wherein the heater element has at least one arcuate section that is concentric with the longitudinal axis of the bubble forming chamber; such that during use, the arcuate section forms a disc-shaped bubble with a point of collapse substantially on the central axis of the bubble forming chamber, the heater element configured such that an actuation energy of less than 500 nanojoules is required to heat the heater element

Art Unit: 2853

sufficiently to form a bubble to cause the ejection of a drop, and except for a structure incorporating nozzles formed by chemical vapor deposition (CVD).

Silverbrook teaches the heater element [440] and bubble forming [447] chamber being symmetrical about a longitudinal plane in [Col. 8, Lines 48-49] shown in Fig. 13 (the heater element [440] and the bubble forming chamber [447] are concentric with each other, therefore symmetrical about any longitudinal plane). Silverbrook teaches the heater element having at least one arcuate section (the curved segment of [441 and 443]) that is concentric with the longitudinal axis of the bubble forming chamber in [Col. 8, Lines 48-49], the bubble forming chamber [447] having a circular cross section in Fig. 13, and the arcuate section [441 and 443] forming a disc-shaped bubble with a point of collapse substantially on the central axis of the bubble forming chamber [447] in [Col. 8, Lines 42-50] shown in Fig. 13 (the annular ink vapour bubble of [Col. 8, Line 50] will collapse substantially on the central axis of the bubble forming chamber as an insulation layer [132] which is concentric with the bubble forming chamber protects the heater [120] from a collapsing vapour bubble in [Col. 7, Lines 6-11] in Fig. 12). Silverbrook teaches that typically 200 nanojoules is required to eject a drop by heating the heater element in [Col. 18, Lines 15-18]. Silverbrook teaches a thick chemical vapor deposition (CVD) glass over coat [142] which forms the nozzle region in [Col. 9, Lines 57-58] shown in Fig. 12.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the heater and bubble forming chamber structure, the requirement of applying a typical heating energy of 200 nanojoules, and a

nozzle plate formed by chemical vapor deposition (CVD) of Silverbrook to the heating element and printhead of Ims in view of Keil et al. for the purpose of producing annular ink vapour bubbles that exerts near equal pressure to all sides of the ink drop [446] in [Col. 8, Lines 48-52], maintaining print speed while reducing power dissipation, and to provide mechanical strength to resist the shock of exploding or collapsing vapor bubbles and to provide protection against the external environment in [Col. 8, Lines 22-25].

4. Claims 5 and 24 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) as applied to claims 1 and 19 above, and further in view of Dunn (US Pat. 4,982,199).

Ims in view of Keil et al. disclose the basic elements of the claimed invention except for the bubble forming liquid and the ejectable liquid being a common body of liquid.

Dunn teaches the bubble forming liquid and the ejectable liquid common to each other in [Col. 2, Lines 31-38] (the bubble is created from the same ink as the ink that is ejected).

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the teachings of Dunn with the printhead of lms in view of Keil et al. for the purpose of heating the same ink with a heater to create a bubble to cause the ejection of ink.

5. Claims 6, 7, 11, 18, 23, 25, 26, 30, and 37 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) as applied to claims 1 and 19 above, and further in view of Kubby (US Pat. 5,706,041).

Ims in view of Keil et al. disclose the basic elements of the claimed invention except for a page-width printhead configuration, the heater element in the form of a cantilever beam, the heater element having two opposite sides and configured such that a gas bubble formed by the heater element is formed at both of the sides of the heater element, supporting the bubble forming liquid in thermal contact with each heater element and ejectable liquid adjacent each nozzle, and the heater element substantially covered by a conformal protective coating, all sides of the coating being seamless.

Kubby teaches the printhead extending across the entire width of the sheet.

Kubby teaches the heater element in the form of a suspended or cantilever beam [18] in [Col. 3, Lines 53-55]. Kubby teaches the heater element [20a and 20b] causing a gas bubble to be formed on both sides of the heater element [20a or 20b] in [Col. 4, Lines 59-63]. Kubby teaches a configuration to support the bubble forming liquid in thermal contact with each said heater element, and to support the ejectable liquid adjacent each nozzle in [Col. 3, Lines 13-24] shown in Fig. 2. Kubby teaches a heater element [20a or 20b] that is substantially covered by a protective coating substantially to all sides, which are seamless in [Col. 4, Lines 32-50] shown in Fig. 4.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the elements taught by Kubby to the

printhead of Ims in view of Keil et al. for the purpose of placing an image on a sheet in a single pass, exposing both sides of the heater for vaporizing liquid ink, ejecting a sufficient amount of ink from the ejector, properly heating the ink, and protecting the heater.

6. Claims 9 and 28 are rejected under 35 U.S.C. 103(a) as being unpatentable over lms (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) as applied to claims 1 and 19 above, and further in view of Silverbrook (US Pat. 5,856,836).

Ims in view of Keil et al. discloses the basic elements of the claimed invention except for the printhead configured to receive a supply of the ejectable liquid at an ambient temperature, wherein each heater element is configured such that the energy required to be applied to heat the heater element to cause ejection of an ink drop is less than the energy required to heat a volume of an ejectable liquid equal to the volume of the ink drop, from an ambient temperature to the boiling point.

Silverbrook ('836) teaches in [Col. 4, Lines 59-65] comprising a thermally activated liquid ink printing head being characterized by the energy required to eject a drop of ink being less than the energy required to raise the temperature of the received supply of ink of a volume equal to the volume of said ink drop above the ambient ink temperature to below ejection temperature. Ejection temperature is referred to in Claims 1 and 19 as the temperature above boiling point. Therefore, "below ejection temperature" would include the boiling point.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the teaching of Silverbrook with the printhead of Ims in view of Keil et al. for the purpose of providing a higher nozzle density per row, a manufacturing process for the printhead with low production costs, and to dissipate the full amount of the active power in the printed ink itself.

7. Claims 10 and 29 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) as applied to claims 1 and 19 above, and further in view of Feinn et al. (US Pat. 6,543,879).

Ims in view of Keil et al. discloses the basic elements of the claimed invention except for a nozzle density greater than 10000 nozzles/cm².

Feinn et al. teaches in [Col. 2, Lines 1-14] a nozzle packing density of at least 100 nozzles/mm², which is equal to 10000 nozzles/cm² when converted to square centimeters.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the nozzle density of Feinn et al. to the printhead of Ims in view of Keil et al. for the purpose of accommodating higher printing resolutions and to improve the printhead drop generation rate in [Col. 1, Lines 57-61].

8. Claims 14 and 33 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) as applied to claims 1 and 19 above, and further in view of Kashino et al. (US Pat. 5,534,898).

Art Unit: 2853 .

Ims in view of Keil et al. discloses the basic elements of the claimed invention except for a nozzle plate of the printhead having a thickness of less than 10 microns.

Kashino et al. teaches a thickness of an orifice plate in the order of several microns in [Col. 6, Lines 34-41].

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the thickness of the Kashino et al. nozzle plate to the Ims in view of Keil et al. printhead for the purpose of obtaining adequate values of the velocity of the discharged ink droplets, amount of ink droplet and refilling frequency, and in consideration of the distance between the thermal energy generating element and the discharge port.

9. Claims 15 and 34 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) as applied to claims 1 and 19 above, and further in view of Komuro (US Pat. 4,965,594).

Ims in view of Keil et al. discloses the basic elements of the claimed invention except for a plurality of nozzle chambers each corresponding to a respective nozzle, and a plurality of said heater elements being disposed within each chamber, the heater elements within each chamber being formed on different respective layers to one another.

Komuro teaches heating resistors [11A, 21, and 31] of a first, second, and third layer formed on different respective layers and a plurality of nozzles [2] having

chambers [4] with heaters [11A, 21, and 31] disposed within in [Cols. 3 and 4, Lines 25-68 and 1-34] shown in Figs. 1-4.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the stated structure of Komuro with the printhead of Ims in view of Keil et al. for the purpose of keeping discharge speed and frequency characteristics in a stable manner.

10. Claims 16 and 35 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) as applied to claims 1 and 19 above, and further in view of Chan (US Pat. 5,710,070).

Ims in view of Keil et al. disclose the basic elements of the claimed invention except for a heater element formed of solid material of which more than 90% of which, by atomic proportion, is constituted by at least one periodic element having an atomic number below 50.

Chan teaches a thermal inkjet printhead comprising a resistive layer composed of titanium nitride, which forms a resistor and a contact metal barrier layer in [Col. 2, Lines 10-14]. Titanium has an atomic number less than 50 on the periodic table.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the titanium nitride resistor to the printhead of Ims in view of Keil et al. for the purpose of having resistors that are more reliable, especially at higher temperatures and less complicated to manufacture.

Art Unit: 2853

11. Claims 17 and 36 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) as applied to claims 1 and 19 above, and further in view of Pan et al. (US Pat. 4,931,813).

Ims in view of Keil et al. discloses the basic elements of the claimed invention except for the heater element configured to a mass of less than 10 nanograms.

Pan et al. discloses the heater element including a solid that is heated to form a bubble vapor to cause ejection of an ink drop, but does not explicitly teach the solid having a mass less than 10 nanograms. It would have been obvious at the time the invention was made to a person having ordinary skill in the art at the time the invention was made to apply at least 10 nanograms of the solid material to the heating element of Ims in view of Keil et al. to cause an ejection of an ink drop since it has been held that discovering an optimum value of a result effective variable involves only routine skill in the art. In re Boesch, 617 F.2d 272, 205 USPQ (CCPA 1980.)

12. Claims 38, 41, and 48 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) and Fukuchi et al. (US Pat. 4,549,191).

Referring to claims 38 and 48, Ims discloses the basic elements of the claimed invention. Ims teaches an ink jet printhead [10] in [Col. 4, Line 48] shown in Fig. 1. and a printer system in [Col. 4, Lines 7-9]. Ims teaches a plurality of nozzles in [Col. 8, Lines 44-45]. Ims teaches a heater associated with each of the nozzles respectively in [Col. 8, Lines 6-11] and the heater having at least one heater element configured for

thermal contact with a bubble forming liquid; such that, heating the heater element above the boiling point of the bubble forming liquid forms a gas bubble that ejects a drop of ejectable liquid from the nozzle in [Col. 5, Lines 39-50]. Ims does not teach the gas bubble subsequently collapsing to a point of collapse that is spaced from any solid surface of the heater elements or the bubble forming chamber. Ims does not teach supplying the nozzle with a replacement volume of the ejectable liquid equivalent to the ejected drop.

Keil et al. teaches a bubble collapse occurring at a location well spaced from any solid surface within the inkjet printhead such as the heat transducer [34] in [Col. 4, Lines 48-56] shown in Figs. 3-5 ("spaced from any solid surface" does not mean "spaced from every single surface").

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the teaching of Keil et al. with the printhead of Ims for the purpose of extending the life of the heat transducer [34].

Fukuchi et al. teaches replacing an amount equal in volume to the ink that was ejected from the nozzles in [Col. 1, Lines 35-38].

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the teaching of Fukuchi et al. with the modified printhead of lms for the purpose of preventing ink degeneration in the pressure chamber in [Col. 3, Lines 51-58].

Referring to claim 41, Ims teaches the gas bubble encircles at least some of the heater element in [Col. 5, Lines 44-51]. ("bubble or water vapor thermally isolates the ink from the heating element" means that bubble is surrounding the heating element.)

13. Claims 39, 40, 44, and 50 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) and Fukuchi et al. (US Pat. 4,549,191) as applied to claim 38 above, and further in view of Silverbrook (US Pat. 5,841,452).

Ims in view of Keil et al. and Fukuchi et al. disclose the basic elements of the claimed invention except for the heater elements and bubble forming chamber being symmetrical about a longitudinal plane, the bubble forming chamber having a circular cross section wherein the heater element has at least one arcuate section that is concentric with the longitudinal axis of the bubble forming chamber; such that during use, the arcuate section forms a disc-shaped bubble with a point of collapse substantially on the central axis of the bubble forming chamber, the heater element configured such that an actuation energy of less than 500 nanojoules is required to heat the heater element sufficiently to form a bubble to cause the ejection of a drop, and except for a structure incorporating nozzles formed by chemical vapor deposition (CVD).

Silverbrook teaches the heater element [440] and bubble forming [447] chamber being symmetrical about a longitudinal plane in [Col. 8, Lines 48-49] shown in Fig. 13 (the heater element [440] and the bubble forming chamber [447] are concentric with

each other, therefore symmetrical about any longitudinal plane). Silverbrook teaches the heater element having at least one arcuate section (the curved segment of [441 and 443]) that is concentric with the longitudinal axis of the bubble forming chamber in [Col. 8, Lines 48-49], the bubble forming chamber [447] having a circular cross section in Fig. 13, and the arcuate section [441 and 443] forming a disc-shaped bubble with a point of collapse substantially on the central axis of the bubble forming chamber [447] in [Col. 8, Lines 42-50] shown in Fig. 13 (the annular ink vapour bubble of [Col. 8, Line 50] will collapse substantially on the central axis of the bubble forming chamber as an insulation layer [132] which is concentric with the bubble forming chamber protects the heater [120] from a collapsing vapour bubble in [Col. 7, Lines 6-11] in Fig. 12). Silverbrook teaches that typically 200 nanojoules is required to eject a drop by heating the heater element in [Col. 18, Lines 15-18]. Silverbrook teaches a thick chemical vapor deposition (CVD) glass over coat [142] which forms the nozzle region in [Col. 9, Lines 57-58] shown in Fig. 12.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the heater and bubble forming chamber structure, the requirement of applying a typical heating energy of 200 nanojoules, and a nozzle plate formed by chemical vapor deposition (CVD) of Silverbrook to the heating element and printhead of lms in view of Keil et al. and Fukuchi et al. for the purpose of producing annular ink vapour bubbles that exerts near equal pressure to all sides of the ink drop [446] in [Col. 8, Lines 48-52], maintaining print speed while reducing power dissipation, and to provide mechanical strength to resist the shock of exploding or

collapsing vapor bubbles and to provide protection against the external environment in [Col. 8, Lines 22-25].

14. Claim 42 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) and Fukuchi et al. (US Pat. 4,549,191) as applied to claim 38 above, and further in view of Dunn (US Pat. 4,982,199).

Ims in view of Keil et al. and Fukuchi et al. disclose the basic elements of the claimed invention except for the bubble forming liquid and the ejectable liquid being a common body of liquid.

Dunn teaches the bubble forming liquid and the ejectable liquid common to each other in [Col. 2, Lines 31-38] (the bubble is created from the same ink as the ink that is ejected).

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the teachings of Dunn with the printhead of Ims in view of Keil et al. and Fukuchi et al. for the purpose of heating the same ink with a heater to create a bubble to cause the ejection of ink.

15. Claims 43, 47, and 54 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) and Fukuchi et al. (US Pat. 4,549,191) as applied to claim 38 above, and further in view of Kubby (US Pat. 5,706,041).

Ims in view of Keil et al. and Fukuchi et al. discloses the basic elements of the claimed invention except for a page-width printhead configuration, the heater element having two opposite sides and configured such that a gas bubble formed by the heater element is formed at both of the sides of the heater element, and the heater element substantially covered by a conformal protective coating, all sides of the coating being seamless.

Kubby teaches the printhead extending across the entire width of the sheet.

Kubby teaches the heater element [20a and 20b] causing a gas bubble to be formed on both sides of the heater element [20a or 20b] in [Col. 4, Lines 59-63]. Kubby teaches a heater element [20a or 20b] that is substantially covered by a protective coating substantially to all sides, which are seamless in [Col. 4, Lines 32-50] shown in Fig. 4.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the elements taught by Kubby to the printhead of Ims in view of Keil et al. and Fukuchi et al. for the purpose of placing an image on a sheet in a single pass, properly heating the ink, and protecting the heater.

16. Claim 45 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) and Fukuchi et al. (US Pat. 4,549,191) as applied to claim 38 above, and further in view of Silverbrook (US Pat. 5,856,836).

Ims in view of Keil et al. and Fukuchi et al. discloses the basic elements of the claimed invention except for the printhead configured to receive a supply of the

ejectable liquid at an ambient temperature, wherein each heater element is configured such that the energy required to be applied to heat the heater element to cause ejection of an ink drop is less than the energy required to heat a volume of an ejectable liquid equal to the volume of the ink drop, from an ambient temperature to the boiling point.

Silverbrook ('836) teaches in [Col. 4, Lines 59-65] comprising a thermally activated liquid ink printing head being characterized by the energy required to eject a drop of ink being less than the energy required to raise the temperature of the received supply of ink of a volume equal to the volume of said ink drop above the ambient ink temperature to below ejection temperature. Ejection temperature is referred to in Claim 38 as the temperature above boiling point. Therefore, "below ejection temperature" would include the boiling point.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the teaching of Silverbrook with the printhead of Ims in view of Keil et al. and Fukuchi et al. for the purpose of providing a higher nozzle density per row, a manufacturing process for the printhead with low production costs, and to dissipate the full amount of the active power in the printed ink itself.

17. Claim 46 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) and Fukuchi et al. (US Pat. 4,549,191) as applied to claim 38 above, and further in view of Feinn et al. (US Pat. 6,543,879).

Art Unit: 2853

Ims in view of Keil et al. and Fukuchi et al. discloses the basic elements of the claimed invention except for a nozzle density greater than 10000 nozzles/cm².

Feinn et al. teaches in [Col. 2, Lines 1-14] a nozzle packing density of at least 100 nozzles/mm², which is equal to 10000 nozzles/cm² when converted to square centimeters.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the nozzle density of Feinn et al. to the printhead of Ims in view of Keil et al. and Fukuchi et al. for the purpose of accommodating higher printing resolutions and to improve the printhead drop generation rate in [Col. 1, Lines 57-61].

18. Claim 49 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) and Fukuchi et al. (US Pat. 4,549,191) as applied to claim 38 above, and further in view of Kashino et al. (US Pat. 5,534,898).

Ims in view of Keil et al. and Fukuchi et al. discloses the basic elements of the claimed invention except for a nozzle plate of the printhead having a thickness of less than 10 microns.

Kashino et al. teaches a thickness of an orifice plate in the order of several microns in [Col. 6, Lines 34-41].

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the thickness of the Kashino et al. nozzle

plate to the Ims in view of Keil et al. and Fukuchi et al. printhead for the purpose of obtaining adequate values of the velocity of the discharged ink droplets, amount of ink droplet and refilling frequency, and in consideration of the distance between the thermal energy generating element and the discharge port.

19. Claim 51 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) and Fukuchi et al. (US Pat. 4,549,191) as applied to claim 38 above, and further in view of Komuro (US Pat. 4,965,594).

Ims in view of Keil et al. and Fukuchi et al. discloses the basic elements of the claimed invention except for a plurality of nozzle chambers each corresponding to a respective nozzle, and a plurality of said heater elements being disposed within each chamber, the heater elements within each chamber being formed on different respective layers to one another.

Komuro teaches heating resistors [11A, 21, and 31] of a first, second, and third layer formed on different respective layers and a plurality of nozzles [2] having chambers [4] with heaters [11A, 21, and 31] disposed within in [Cols. 3 and 4, Lines 25-68 and 1-34] shown in Figs. 1-4.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the stated structure of Komuro with the printhead of Ims in view of Keil et al. and Fukuchi et al. for the purpose of keeping discharge speed and frequency characteristics in a stable manner.

Application/Control Number: 10/773,199 Page 20

Art Unit: 2853

20. Claim 52 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) and Fukuchi et al. (US Pat. 4,549,191) as applied to claim 38 above, and further in view of Chan (US Pat. 5,710,070).

Ims in view of Keil et al. and Fukuchi et al. disclose the basic elements of the claimed invention except for a heater element formed of solid material of which more than 90% of which, by atomic proportion, is constituted by at least one periodic element having an atomic number below 50.

Chan teaches a thermal inkjet printhead comprising a resistive layer composed of titanium nitride, which forms a resistor and a contact metal barrier layer in [Col. 2, Lines 10-14]. Titanium has an atomic number less than 50 on the periodic table.

It would have been obvious at the time the invention was made to a person having ordinary skill in the art to incorporate the titanium nitride resistor to the printhead of Ims in view of Keil et al. and Fukuchi et al. for the purpose of having resistors that are more reliable, especially at higher temperatures and less complicated to manufacture.

21. Claim 53 is rejected under 35 U.S.C. 103(a) as being unpatentable over Ims (US Pat. 4,797,692) in view of Keil et al. (US Pat. 6,447,104) and Fukuchi et al. (US Pat. 4,549,191) as applied to claim 38 above, and further in view of Pan et al. (US Pat. 4,931,813).

Art Unit: 2853

Ims in view of Keil et al. and Fukuchi et al. discloses the basic elements of the claimed invention except for the heater element configured to a mass of less than 10 nanograms.

Page 21

Pan et al. discloses the heater element including a solid that is heated to form a bubble vapor to cause ejection of an ink drop, but does not explicitly teach the solid having a mass less than 10 nanograms. It would have been obvious at the time the invention was made to a person having ordinary skill in the art at the time the invention was made to apply at least 10 nanograms of the solid material to the heating element of Ims in view of Keil et al. and Fukuchi et al. to cause an ejection of an ink drop since it has been held that discovering an optimum value of a result effective variable involves only routine skill in the art. In re Boesch, 617 F.2d 272, 205 USPQ (CCPA 1980.)

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Han S. Choi whose telephone number is (571) 272-8350. The examiner can normally be reached on Monday - Friday, 8:30am to 5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Stephen Meier can be reached on (571) 272-2149. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Art Unit: 2853

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

HSC 11/20/06 Julian D. Huffman Art Unit 2853 21 November 2006

Page 22